## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Gene LEE et al.

Appln. No.: 10/039,333 Group Art Unit: 1765

Filed: November 9, 2001 Examiner: B. Tran

Title: Method for Etching Tungsten

Using NF 3 and Cl 2

## PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Applicant hereby petitions for a three (3) month extension of time extending the period for reply to the Office Action mailed May 8, 2003 from August 8, 2003 to November 10, 2003 (November 8, 2003 falling on a Saturday). The Director of the U.S. Patent & Trademark Office is hereby authorized to charge the extension of time fee of \$970.00 to Deposit Account No. 18-1579. The Director is also authorized to charge any fee deficiency, or credit any overpayment, to Deposit Account No. 18-1579.

11/13/2003 SSESHE1 00000061 10039333 01 FC:1253 950.00 DA

Respectfully submitted,

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Atty. Dkt. No.: 2316